

**Notice of References Cited**

Application/Control No.

10/541,745

Applicant(s)/Patent Under  
Reexamination  
YAMAMOTO ET AL.

Examiner

MICHAEL E. NELSON

Art Unit

4174

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,013,384 A	01-2000	Kido et al.	428/690
*	B	US-2006/0147747 A1	07-2006	Yamamoto et al.	428/690
*	C	US-2007/0138950 A1	06-2007	Yamamoto et al.	313/504
*	D	US-2007/0200490 A1	08-2007	Kawamura et al.	313/504
*	E	US-2007/0267970 A1	11-2007	Yamamoto et al.	313/506
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2001335776	12-2001	Japan	Okada et al.	
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U				
	V				
	W				
	X				

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.